



**INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE**

**ELECTRONIC COPY**

**LABORATORY GROWN  
DIAMOND REPORT**

**LG632449245**

**IGI LABORATORY GROWN  
DIAMOND ID REPORT**

April 30, 2024  
IGI Report Number **LG632449245**  
**ROUND BRILLIANT**  
**6.25 - 6.28 X 3.78 MM**  
Carat Weight 0.91 CARAT  
Color Grade D  
Clarity Grade VS 1  
Cut Grade IDEAL  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) LG632449245

Comments: HEARTS & ARROWS This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment. Type Ila

**LABORATORY GROWN DIAMOND REPORT**

**IGI LABORATORY GROWN DIAMOND IDENTIFICATION REPORT**

April 30, 2024  
IGI Report Number LG632449245  
Description LABORATORY GROWN DIAMOND  
Shape and Cutting Style ROUND BRILLIANT  
Measurements 6.25 - 6.28 X 3.78 MM

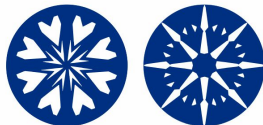
**GRADING RESULTS**

Carat Weight 0.91 CARAT  
Color Grade D  
Clarity Grade VS 1  
Cut Grade IDEAL

**ADDITIONAL GRADING INFORMATION**

Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) LG632449245

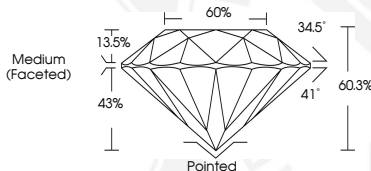
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**HEARTS & ARROWS**



Sample Image Used



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For terms & conditions and to verify this report, please visit [www.igi.org](http://www.igi.org)

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